


Personal Information

Full name	Jiro Matsuo	
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Short Biography

Jiro Matsuo received Ph.D. degree in electrical engineering from Kyoto University. He is an associate professor of Graduate School of Engineering, Kyoto University. In 1984, he joined Fujitsu Co. to develop advanced CMOS device and process. His research interests include ion beam process and characterization for advanced materials and devices. He served as deputy leader of “Cluster Ion Beam Technology” and “Advanced Quantum Beam Project” of MITI, in which collaborative research with many companies were carried out to develop industrial appreciations of cluster ion beam. He was also conducting “3 Dimensional Molecular Imaging for Soft Materials” project and is now project leader of “Liquids-Solids Interface Analysis with SIMS” in SENTA project.